



PTO/SB/08b
Substitute for Form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Application Number		10/576,036	
Filing Date		May 10, 2006	
First Named		Kenji KOHIRO	
Art Unit		Not assigned 1792	
Examiner Name		Not assigned Hiteshew	
Attorney Docket		7372/88139	

Sheet 2 of 2

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T*
/F.H./		NAKAMURA et al., Effect of substrate misorientation on tear-drop-like hillock defect densities in InP and GaInAsP grown by metalorganic chemical vapor deposition, Journal of Crystal Growth, 129:456-464 (1993)	
Examiner Signature	/Felisa Hiteshew/		Date Considered 03/06/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
¹ Applicant's unique citation designation number (optional). * Applicant is to place a check mark here if English language Translation is attached.